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APPLICATION NO.	FIL	LING DATE	FIRST NAMED INVENTOR Jay Rossiter	50277-1786	CONFIRMATION NO. 4251		
09/945,135	0:	8/31/2001					
29989	7590	11/14/2002					
		MO TRUONG &	EXAMINER				
1600 WILLO SAN JOSE,				ALAM, H	ALAM, HOSAIN T		
				ART UNIT	PAPER NUMBER		
				0170			

DATE MAILED: 11/14/2002

Please find below and/or attached an Office communication concerning this application or proceeding.

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	App	plication No.	Applicant(s)					
		/945,135	ROSSITER ET AI	ROSSITER ET AL.				
Office Action Sur	nmary	aminer	Art Unit					
	Hos	sain T Alam	2172					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply								
A SHORTENED STATUTORY THE MAILING DATE OF THIS - Extensions of time may be available unde after SIX (6) MONTHS from the mailing d: - If the period for reply specified above is le - If NO period for reply is specified above, t - Failure to reply within the set or extended - Any reply received by the Office later than earmed patent term adjustment. See 37 C Status	COMMUNICATION. r the provisions of 37 CFR 1.136(a). ste of this communication. ss than thirty (30) days, a reply within e maximum statutory period will app period for reply will, by statute, cause three months after the mailing date of	In no event, however, may a r the statutory minimum of thin ty and will expire SIX (6) MON the application to become AE	reply be timely filed by (30) days will be considered time ITHS from the mailing date of this of BANDONED (35 U.S.C. § 133).					
1) Responsive to communi	cation(s) filed on							
2a) ☐ This action is FINAL .	2b)⊠ This ac	tion is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
Disposition of Claims								
4) Claim(s) <u>1-6</u> is/are pendi	-							
4a) Of the above claim(s)		om consideration.	•					
5) Claim(s) is/are allo								
6)⊠ Claim(s) <u>1-6</u> is/are rejecte								
7) Claim(s) is/are obj								
8) Claim(s) are subject Application Papers	ct to restriction and/or elec	ction requirement.						
9) The specification is object	ed to by the Examiner.							
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.								
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
11) ☐ The proposed drawing correction filed on is: a) ☐ approved b) ☐ disapproved by the Examiner.								
If approved, corrected drawings are required in reply to this Office action.								
12)☐ The oath or declaration is objected to by the Examiner.								
Priority under 35 U.S.C. §§ 119 a	nd 120							
13) Acknowledgment is made	e of a claim for foreign price	rity under 35 U.S.C.	§ 119(a)-(d) or (f).					
a)□ All b)□ Some * c)□	None of:							
1. Certified copies of	the priority documents have	e been received.						
2. Certified copies of	the priority documents have	e been received in A	pplication No					
	ied copies of the priority d n the International Bureau Office action for a list of th	(PCT Rule 17.2(a)).		Stage				
14) Acknowledgment is made		•		al application).				
a) The translation of the	•	<u>-</u>		,				
15) Acknowledgment is made		• •						
Attachment(s)								
1) Notice of References Cited (PTO-892 2) Notice of Draftsperson's Patent Draw 3) Information Disclosure Statement(s)	ing Review (PTO-948)		Summary (PTO-413) Paper No Informal Patent Application (PT					

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DETAILED ACTION

Claims 1-6 are pending in this Office Action

Information Disclosure Statement

The information disclosure statement filed in Paper No. 2, 6, and 8 have been considered.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in-

(1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effect under this subsection of a national application published under section 122(b) only if the international application designating the United States was published under Article 21(2)(a) of such treaty in the English language; or

(2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that a patent shall not be deemed filed in the United States for the purposes of this subsection based on the filing of an international application filed under the treaty defined in section 351(a).

Claims 1-6 are rejected under 35 U.S.C. 102(e) as being anticipated by U. S. Patent No. 6,240,416 issued to Immon et al. ('Immon')

With respect to claim 1, Immon teaches, a method for managing a system that includes a plurality of devices arranged ion a network as claimed comprising the steps of gathering and storing in a centralized repository metadata (col. 3, lines 23-32) that reflects configuration information about the system and each of the devices;

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modifying metadata within the centralized repository to initiate configuration changes in the network (col. 12, lines 13-17); and propagating said changes from the repository to the devices in the network to cause said configuration changes (col. 12, lines 30-32).

With respect to claim 3, which is dependent on claim 1, Immon teaches a centralized metadata repository resides outside the system (col. 7, line 59).

With respect to claim 2, Immon teaches a method for managing a system that includes a plurality of devices arranged ion a network as claimed comprising the steps of gathering and storing in a centralized repository metadata that reflects configuration information about the system and each of the devices (see the rejection of claim 1 above);

in response to a failure of the system, recovering the central repository from a backup, using metadata within the centralized repository to configure the system, and recovering the system after the system is configured (col., line 57-61).

With respect to claim 4, Immon teaches a method for managing a system that includes a plurality of devices arranged ion a network as claimed comprising gathering and storing in a centralized repository metadata that reflects configuration information about the system and each of the devices; and

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managing configuration of said system based upon the metadata within said centralized repository, and in response to a failure of the system, configuring the system based on the metadata of the repository (col., line 57-61).

With respect to claims 3 and 4, Immon does not explicitly indicate a failure as recited in the claims. Immon however teaches the "difference between the metadata in the system record and that of a source"(col. 8, lines 20-22) and in addition, Immon teaches refreshing the metadata (col. 12, lines 13-14). Immon therefore implicitly teaches a source of consistent metadata data which can be used as a backup. Immon does not recite "backup" but discloses the functionalities to realize a backup process (i.e., synchronization, col. 11-12), and therefore implicitly discloses a backup process. See MPEP 2144.01 for Implicit Disclosure:

"[I]n considering the disclosure of a reference, it is proper to take into account not only specific teachings of the reference but also the inferences which one skilled in the art would reasonably be expected to draw therefrom." In re Preda, 401 F.2d 825, 826, 159 USPQ 342, 344 (CCPA 1968) (A process for catalytically producing carbon disulfide by reacting sulfur vapor and methane in the presence of charcoal at a temperature of "about 750-830C" was found to be met by a reference which expressly taught the same process at 700C because the reference recognized the possibility of using temperatures greater than 750C. The reference disclosed that catalytic processes for converting methane with sulfur vapors into carbon disulfide at temperatures greater than 750C (albeit without charcoal) was known, and that 700C was "much lower than had previously proved feasible."); In re Lamberti, 545 F.2d 747, 750, 192 USPQ 278, 280 (CCPA 1976) (Reference disclosure of a compound where the R-S-R¢ portion has "at least one methylene group attached to the sulfur atom" implies that the other R group attached to the sulfur atom can be other than methylene and therefore suggests asymmetric dialkyl moieties.).

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With respect to claim 5, Immon teaches a method for managing a system that includes a plurality of devices arranged ion a network as claimed comprising gathering and storing in a centralized repository metadata that reflects configuration information about the system and each of the devices; replicating said system(col. 11-12, "AUTOMATIC SYSNCHRONIZATION) by performing the steps of copying said metadata (col. 12, line 13-16) to a second centralized metadata repository associated with a second system, and configuring the second system based on the metadata contained in said second metadata repository (Immon implicitly discloses a plurality of metadata repositories wherein any one of the repositories can be used as a second or backup repository; see col. 8, lines 1-25, and col. 12, lines 1-32; col. 6, lines 32-35 ..."any participating site")

With respect to claim 6, Immon teaches a method for managing a system that includes a plurality of devices arranged ion a network as claimed comprising gathering and storing in a centralized repository metadata that reflects configuration information about the system and each of the devices; and managing configuration of at least two of an application layer (col. 7, lines 9-11), an operating system layer (col. 7, lines 16-18), and a hardware layer of said system based upon the metadata within said centralized repository. The examiner notes that the "deadlock metadata" as taught by Immon deals with "transaction processing" while the "system of record metadata" deals with analytical processing. In col. 7, Immon addressee the system performance issues as well as the issues of access and analysis of data. Transaction processing affects the system

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performance in terms of I/O operations, involving the resources at the operating system level.

Prior Art

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

"An Overview of Data Warehousing and OLAP Technology," Chaudhuri et al., ACM SIGMOD, Vol. 26, No. 1, pages 65-74, March, 1997.

Contact Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hosain T Alam whose telephone number is (703) 308-6662. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kim Y Vu can be reached on (703) 305-4393. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-6606 for regular communications and (703) 308-6606 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 305 3800.

The following contact numbers may also be used:

TC 2100 After Finals number is 703-746-7238

TC 2100 Official Fax number is 703-746-7239

TC 2100 Customer Service Center is 703-746-7240

Hosain T Alam Primary Examiner Art Unit 2172

November 8, 2002